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MAIL STOP: Amendment on December 4, 2008.

TOWNSEND and TOWNSEND and CREW LLP

By: 
Cindy Barrett

PATENT
Attorney Docket No.: 016301-047800US
Client Ref. No.: AMAT No.
007188/DISPLAY/AKT/BG

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sheng Sun et al.

Application No.: 10/817,611

Filed: April 2, 2004

For: METHOD AND SYSTEM FOR CONTROL
OF PROCESSING CONDITIONS IN
PLASMA PROCESSING SYSTEMS

Customer No.: 57385

Confirmation No. 2449

Examiner: Bashore, Alain L.

Technology Center/Art Unit: 1792

AMENDMENT

MAIL STOP: AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed September 4, 2008 (the "Office Action"),
please enter the following remarks:

A Listing of Claims begins on page 2 of this paper.

Remarks begin on page 8 of this paper.